

Stabilization of the Nano-Sized 1T Phase through Rhenium Doping in the Metal–Organic CVD MoS₂ Films

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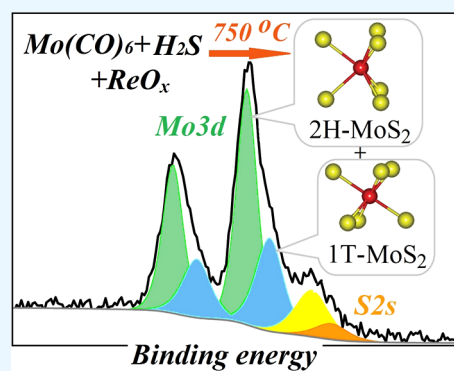
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ABSTRACT: Heterogeneous nanostructures composed of metastable tetragonal 1T-MoS₂ and stable hexagonal 2H-MoS₂ phases are highly promising for a wide range of applications, including catalysis and ion batteries, due to the high electrical conductivity and catalytic activity of the 1T phase. However, a controllable synthesis of stabilized 1T-MoS₂ films over the wafer-scale area is challenging. In this work, a metal–organic chemical vapor deposition process allowing us to obtain ultrathin MoS₂ films containing both 1T and 2H phases and control their ratio through rhenium doping was suggested. As a result, Mo_{1-x}Re_xS₂ films with a 1T-MoS₂ fraction up to ≈30% were obtained, which were relatively stable under normal conditions for a long time. X-ray photoelectron spectroscopy and Raman spectroscopy also indicated that the 1T-MoS₂ phase fraction increased with rhenium concentration increase saturating at Re concentrations above 5 at. %. Also, its concentration was found to significantly affect the film resistivity. Thus, the resistivity of the film containing approximately 30% of the 1T phase was about 130 times lower than that of the film without the 1T phase.



INTRODUCTION

Two-dimensional (2D) transition metals dichalcogenides (TMDCs), in particular MoS₂, represent a specific class of layered materials where neighboring layers are bonded by the weak van der Waals forces. In most cases, TMDCs exist in the form of films containing multiple stable molecular layers with atomically smooth chemically inert surfaces, which naturally results in a number of their outstanding properties.^{1–3} Such films are of interest for nanoelectronic and optoelectronic applications,^{4,5} photovoltaics,^{6,7} photodetectors,^{8,9} and gas sensors.^{10,11} On the other hand, TMDCs may also be prepared in a significantly different form with a high specific surface area and high density of chemically active surface states, which makes them promising for catalysis,^{12–16} ion batteries,¹⁷ and supercapacitors.¹⁸ Three MoS₂ crystalline phases are known, hexagonal (2H), rhombohedral (3R), and tetragonal (1T) with a different coordination of sulfur atoms to molybdenum, which determine the chemical and electronic properties of the material. The 3R-MoS₂ and 1T-MoS₂ phases are metastable and may transform into 2H-MoS₂ under certain conditions.¹⁹ One of the specific features of the 1T-MoS₂ phase is metallic conductivity, attributed to the fact that there are only two electrons at the triply degenerate t_{2g} orbital of the Mo4d level.¹⁹ Another 1T-MoS₂ distinctive feature is improved catalytic activity owing to the active basal states compared to only edge atoms being active in the 2H phase,²⁰ which is attractive for catalysis applications, in particular the hydrogen

evolution reaction.²¹ However, obtaining the 1T phase in MoS₂ films was found to be challenging. One of the possible mechanisms of its synthesis is chemical or electrochemical exfoliation by alkali metal intercalation, accompanied by the electron transfer from the alkali ion to the d-orbital of molybdenum. As a result, the 1T phase becomes more stable compared to the 2H one, but the phase transition is incomplete. Also, the resulting 1T phase is very fragile due to weak interaction between neighboring sulfur layers.²² To improve its stability, doping or intercalation by the electron-donating metal atoms was suggested,^{19,23,24} but the intermediate Li_xMoS₂ and the intercalator of *n*-butyllithium are hazardous and pyrophoric materials.¹⁹ Besides the aforementioned intercalation approach, the 2H-1T phase transition may also be induced by electron beam irradiation,²⁵ plasmonic hot injection,²⁶ or direct hydrothermal synthesis.²⁷ The obtained 1T/2H-MoS₂ heterogeneous structures are significantly more stable than the pure 1T-MoS₂ phase, while the phase coexistence grants their unique properties. In addition to enhanced electrical conductivity and catalytic state density,

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high photoresponse and external quantum efficiency were demonstrated for a photodetector, consisting of the top 2H-MoS₂ and bottom 1T/2H-MoS₂ layers.²⁸ However, the aforementioned synthesis techniques are either quite complex or time-consuming. In this regard, the development of a technological approach that makes it possible to obtain ultrathin films consisting of a combination of 1T/2H-MoS₂ phases, which are stable over a wide temperature range, is still of great practical interest. Up to date, most of the reported results correspond to the 2H-MoS₂ synthesis by chemical vapor deposition (CVD),^{29–31} physical deposition,³² or two-step sulfurization.^{33–35} Among them, metal–organic CVD (MOCVD) recently attracted a great deal of attention because it allows for electronic grade films' uniform deposition over wafer-scale areas and demonstrates the highest controllability.³⁶

Direct 1T-MoS₂ CVD fabrication is extremely challenging due to its thermodynamic instability. However, 1T phase formation was reported in monolayer CVD Mo_{1–x}W_xS₂ deposited onto substrates with a thermal expansion coefficient higher than that of MoS₂ and WS₂ films.³⁷ In this case, transition to the 1T phase is induced by compressive thermal strains. A number of studies mention Re doping utilization for 1T-MoS₂ phase stabilization.^{19,38,39} Such treatment provides excess electrons that fill the Mo higher energy levels (d_{xy} , $d_{x^2-y^2}$), which leads to the transformation of the 2H structure into 1T.

In this work, we report an original MOCVD MoS₂ film doping method through use of ReO_x particles as the rhenium precursor. Moreover, specific MOCVD growth regimes were employed with a low molybdenum precursor concentration and high S/Mo concentration ratio in the gas phase, which allowed for ultrathin Mo_{1–x}Re_xS₂ film synthesis containing the metastable 1T phase. As a result, the influence of the deposition process parameters on the 1T-MoS₂ fraction in the stabilized heterogeneous 1T/2H-MoS₂ structure was investigated.

EXPERIMENTAL SECTION

At the first stage, rhenium oxide was deposited in a three-zone tube furnace HZS-1200 (Carbolite Gero) equipped with a 32 mm outer diameter quartz tube in the air. A crucible containing metallic rhenium (10 g, 99.9% purity) was placed in the center of the heated zone of the tube. Sapphire substrates were placed at the edge of the heated area, where the temperature varied from 240 to 130 °C as shown in Figure S1a. The furnace was heated up to 310 °C and maintained at this temperature for 10 min. Then, the heaters were turned off, allowing the furnace to cool down. At the second stage, the MOCVD processes were carried out in a homemade reactor based on a three-zone tube furnace HZS-1200. Molybdenum hexacarbonyl Mo(CO)₆ (99.98% purity, Sigma-Aldrich) and hydrogen sulfide (H₂S) were used as precursors, while the Ar + 5% H₂ mixture was used as the carrier gas. Mo(CO)₆ was kept in a stainless-steel bubbler held at a temperature of 21.5 °C. The calculated outlet gas flow rates of Mo(CO)₆ were 1.5 × 10^{−3} sccm, 2.5 × 10^{−3} sccm, and 4.1 × 10^{−3} sccm, while the flow rate of H₂S (99.9%) was 15 sccm for all samples. The Ar + 5% H₂ carrier gas flow rate was 600 sccm, which resulted in a working pressure of 25 mBar. The process temperature was fixed at 750 °C. The growth time varied from 2 to 6 h in order to obtain continuous films at various flow rates of Mo(CO)₆. In particular, at the Mo(CO)₆ flow of 1.5 × 10^{−3} sccm, the

continuous monolayer MoS₂ film is formed after about 3 h. Cleaned (piranha solution, deionized water) 20 × 10 mm-size sapphire pieces were used as substrates. Immediately prior to the MOCVD process, the sapphire substrates were annealed for an hour in the air at 1000 °C. The annealing process was carried out at the same three-zone tube furnace which was used for the CVD process. It should be noted that every stage, including ReO_x deposition, substrate annealing, and MOCVD MoS₂ deposition, was carried out in a separate quartz tube.

The deposition process was carried out as follows: Annealed sapphire substrates were placed in the central zone of the tube furnace. Substrates with pre-deposited rhenium oxide obtained at the first stage were placed upstream in the tube, toward the gas inlet (Figure S1b). The system was pumped down to a pressure below 0.1 hPa prior to the start of the process. The heating step was carried out in a continuous carrier gas flow with a temperature ramp rate of 30 °C/min. When the temperature set point was reached, H₂S was supplied to the reactor, and after 10 min of stabilization time, Mo(CO)₆ flow was supplied as well. After the growth process, the heating system was switched off, allowing the furnace to cool down. During the cooling process, down to 450 °C, the H₂S flow was maintained. Below this point, only carrier gas was supplied. In general, a series consisting of 7 samples further named by a combination of Mo(CO)₆ flow, process time, and rhenium treatment was fabricated (see Table S1 for the description). After the growth, samples were annealed under high-vacuum (2 × 10^{−6} mBar) conditions ($T = 200$ °C) for 2 h to remove the sulfur excess.

The films' chemical state and composition were analyzed by X-ray photoelectron spectroscopy (XPS) in a Theta Probe spectrometer (Thermo Scientific) with a monochromatic Al-Kα X-ray source (1486.6 eV). For such analysis, the grown films were immediately transferred from the furnace to the XPS load lock and pumped down to a pressure of 1.5 × 10^{−7} mBar for about 20 min and then transferred to the analysis chamber kept at a pressure of 2.0 × 10^{−9} mBar. Photoelectron spectra were acquired using the fixed analyzer transmission mode with 50 eV pass energy under the charge compensation mode.

The films' morphology was examined by atomic force microscopy (AFM) on an NT-MDT NTEGRA tool in a semi-contact mode using a silicon tip with a radius <10 nm (HAN-C, SCANSENS). To measure film thickness, it was successively immersed in KOH solution and water and then transferred onto a pristine substrate, where the step profile was measured by AFM (Figure S2 represents the data measured for the Mo1.5–3 film). The film structural analysis was performed on a Tecnai G2transmission electron microscope operated at an accelerating voltage of 200 kV. Raman spectroscopy was used to get insights into the detailed film structure. A LabRAM Evolution (Horiba Scientific) instrument with a 532 nm laser source with 1 cm^{−1} spectral resolution was used to perform the spectral measurements. A diffraction grating of 1800 lines/mm and a 100× objective lens (numerical aperture = 0.90) were utilized in these experiments. The laser spot diameter was 0.45 μm. The laser intensity was kept below 0.5 mW to ensure that laser-induced heating does not introduce artifacts. The film sheet resistance was estimated by a four-probe method using a Keysight B1500A measurement unit connected to a Cascade Microtech Summit probe station with DCP-HTR tungsten probes. The resistance was measured at five different points for each sample.

RESULTS AND DISCUSSION

Figure S3 presents the AFM image of a sapphire substrate covered with rhenium oxide particles, which was used in the consequent MOCVD process. These particles ranged in size from about 10 to 300 nm. In Figure S4, the XPS spectrum of Re4f core levels of this sample is provided. The spectrum was decomposed into two doublets. The major one with a binding energy (BE) of line Re4f_{7/2} of 46.2 eV corresponds to the Re₂O₇ compound. An additional doublet with a BE of line Re4f_{7/2} of 43.6 eV corresponds to ReO₂. In order to control the result reproducibility, each sample with rhenium oxide was investigated using AFM and XPS techniques prior its use in the MoS₂ MOCVD process. Figure 1 presents the AFM image of

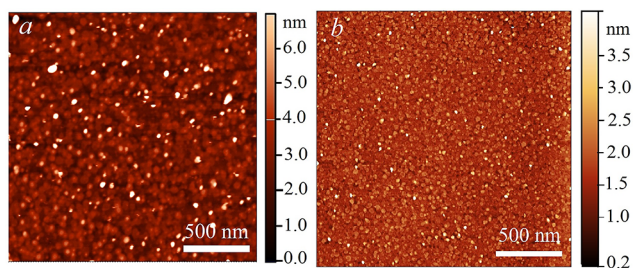


Figure 1. AFM image of Mo_{2.5-4} (a) and Mo_{2.5-4-Re} (b) films.

Mo_{2.5-4} and Mo_{2.5-4-Re} samples, which demonstrates a fine-grained continuous film, with a grain size of several tens of nanometers. For the rhenium-doped sample, slight grain size decrease is observed. The estimated root-mean-square value for these samples was calculated to be 0.38 and 0.23 nm, respectively.

Transmission electron microscopy (TEM) analysis (Figure S5) revealed that the investigated film is polycrystalline with an average grain size of 30–50 nm. The analysis of the corresponding high-resolution TEM image (Figure 2) shows

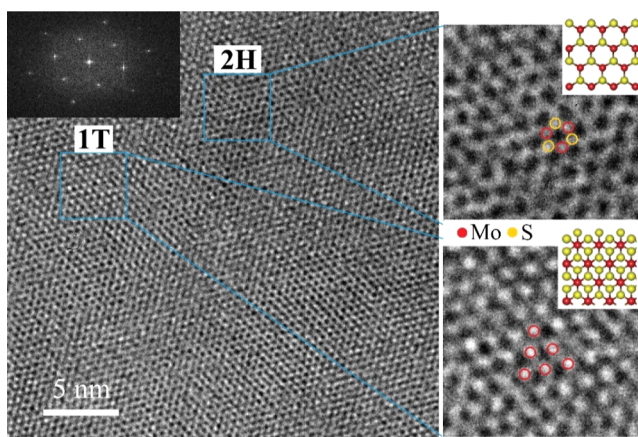


Figure 2. Plan-view high-resolution TEM images of the Mo_{2.1-4} film.

that the crystalline structure is locally distorted due to the presence of point defects. Moreover, as the close investigation of the areas in blue frames suggests, several regions are characterized by a trigonal lattice (octahedral coordination), which is a clear fingerprint of the 1T phase, while other regions have a honeycomb lattice (trigonal prismatic coordination) of the 2H phase.

In Figures 3–5, XPS spectra of Mo3d, S2p, and Re4f core levels for Mo_{1.5-6}, Mo_{1.5-6-Re}, Mo_{2.5-4-Re}, and Mo_{4.1-2-Re} films are presented. All spectra were decomposed into two doublets. For Mo3d spectral decomposition, the first doublet with a BE of the Mo3d_{5/2} line of 229.6–229.7 (eV) and a spin–orbit splitting of 3.15 eV is typical of the 2H structure. The second one with a BE for the Mo3d_{5/2} line of 228.7–228.8 (eV) and similar spin–orbit splitting is associated with the 1T structure, which confirms the TEM analysis result (Figure 3).²⁰ For the corresponding S2p decompositions, the first doublet with a BE for the S2p_{3/2} line of 162.5–162.6 eV and a spin–orbit splitting of 1.1 eV corresponds to the 2H structure,³⁹ while the second one with a BE of 161.6–161.7 eV is associated with the 1T phase (Figure 4). The Re4f spectrum was decomposed into the doublets with a BE of line Re4f_{7/2} of 41.4 eV (corresponding to the 2H structure) and 40.5 eV (corresponding to the 1T structure) (Figure 5).³⁹ In addition, a weak Re4f_{7/2} doublet is observed in the spectra, with a BE of approximately 45.4–45.7 eV, corresponding to ReO₃ or Re₂O₇ oxides. The fraction of oxidized rhenium is estimated to be 7–8%. The phase composition estimation based on these spectra resulted in a 0, 31, 28, and 17% relative 1T phase fraction for Mo_{1.5-6}, Mo_{1.5-6-Re}, Mo_{2.5-4-Re}, and Mo_{4.1-2-Re} films, respectively. The Re concentration for the respective samples was found to be 0, 8, 5, and 3 (at. %). Moreover, the estimated [S]/([Mo] + [Re]) ratio was found to be 2.1–2.2 for the films under investigation, which exceeds the stoichiometric ratio. The additional annealing under high-vacuum conditions (2 × 10^{−6} mBar) at 200 °C for 2 h resulted in its decrease to the nominal value (2), which was accompanied by a slight Mo3d and S2p line constriction. Therefore, we believe that such a procedure allowed us to remove the excess sulfur.

Raman spectroscopy was employed for additional structural analysis and to further confirm 1T-MoS₂ phase presence (Figure 6). In the 120 to 500 cm^{−1} range, Raman spectra have a series of peaks corresponding to different MoS₂ phases. Since the exciting radiation wavelength of 532 nm is not resonant, only first-order peaks E_{2g}¹ (383 cm^{−1}) and A_{1g} (405 cm^{−1}) should be observed in a perfect 2H-MoS₂ lattice spectrum. However, at higher Mo(CO)₆ flow and for films with the rhenium component, weak peaks appear in the low-frequency region corresponding to the crystal lattice defects. The most intense of them [LA(M)] is observed at 227 cm^{−1}. These peculiarities arise from a small crystalline domain size because they are known to be sensitive to lattice defects⁴⁰ and nanoparticle size.⁴¹ For the films containing Re, besides the 2H phase peaks, the discussed spectra also contain a series of peaks at 150 cm^{−1} (J1), 220 cm^{−1} (J2), and 325 cm^{−1} (J3) and the peak at 285 cm^{−1} (E_{1g}), which confirm the 1T phase presence.^{16,20,39} As Figure 6 demonstrates, as Mo(CO)₆ flow decreases, the intensity of the peaks corresponding to the 1T-MoS₂ phase increases, whereas E_{2g}¹ and A_{1g} peak intensity, corresponding to the 2H-MoS₂ phase, decreases. In addition, these peaks broaden and shift toward lower-wavenumber values by 1 cm^{−1}. In the Mo_{1.5-6-Re} sample spectrum, weak peaks are observed at 160 and 305 cm^{−1}, which likely correspond to E_g-like vibrational modes in the ReS₂ structure.⁴²

Thus, when samples with ReO_x particles are placed in the reactor during the MOCVD process, the deposited MoS₂ film is doped by rhenium. With increased Mo(CO)₆ flow, the MoS₂ film deposition rate increased, whereas the rhenium concentration was maintained at the same level in each process. As a

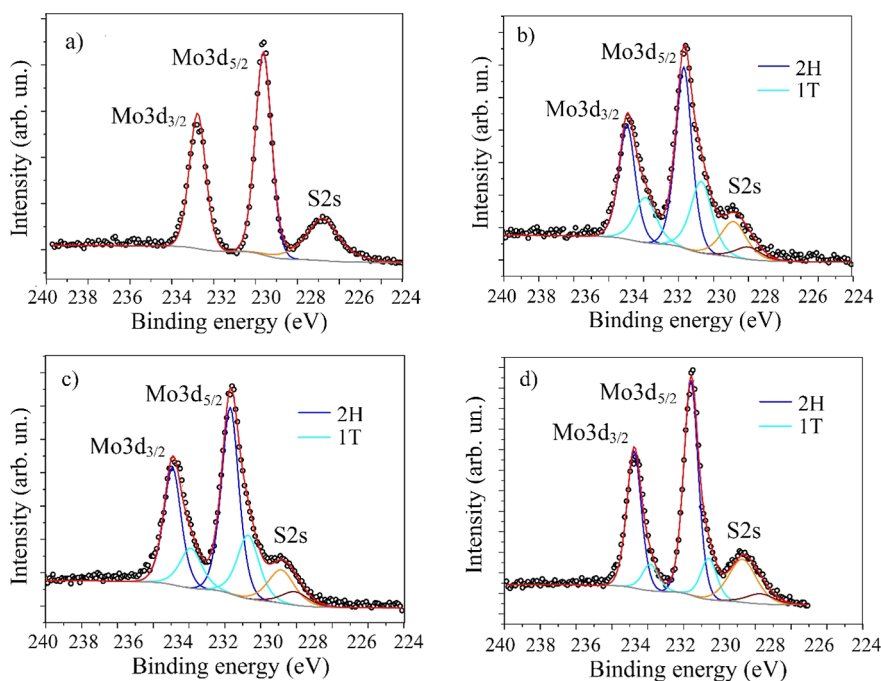


Figure 3. XPS core-level Mo3d spectra of grown $\text{Mo}_{1-x}\text{Re}_x\text{S}_2$ films: Mo1.5-6 (a), Mo1.5-6-Re (b), Mo2.5-4-Re (c), and Mo4.1-2-Re (d).

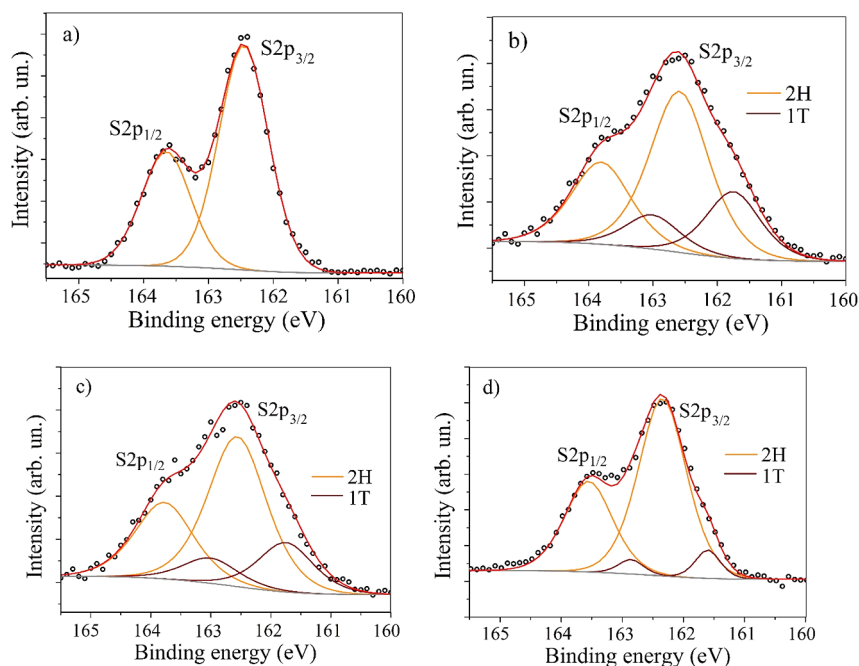


Figure 4. XPS core-level S2p spectra of grown $\text{Mo}_{1-x}\text{Re}_x\text{S}_2$ films: Mo1.5-6 (a), Mo1.5-6-Re (b), Mo2.5-4-Re (c), and Mo4.1-2-Re (d).

result, the rhenium concentration in films is lower at higher $\text{Mo}(\text{CO})_6$ flow. XPS investigation results suggest that for rhenium-doped films, Re and Mo atoms are found in chemical states characteristic of both 2H and 1T phases. With the increased rhenium concentration in films, the 1T- MoS_2 phase fraction also increases. The maximal 1T- MoS_2 phase fraction (31%) corresponds to the maximal Re concentration. However, with the rhenium concentration increasing from 5 to 8 (at. %), 1T fraction increase is significantly weaker, indicating saturation. On the contrary, the rhenium 1T- ReS_2 fraction decreases with the increased Re concentration. The maximal fraction was found to be 65%.

The structural difference of the samples also manifested itself in photoluminescence spectra (Figure 7). Mo1.5-5 and Mo2.5-4 spectra demonstrate the main peak at 1.88–1.86 eV corresponding to A-excitons and a weakly expressed shoulder peak at 1.95 eV, corresponding to B-excitons.^{43,44} In the sample Mo1.5-6-Re spectrum, the intensity of the peak corresponding to A-excitons is considerably lower than that in other samples, its position is shifted toward higher energies (1.92 eV), and the shoulder peak at 2.1 eV corresponding to B-excitons is more distinct.

The synthesized heterogeneous structures containing 1T and 2H phases are stable under ambient conditions without

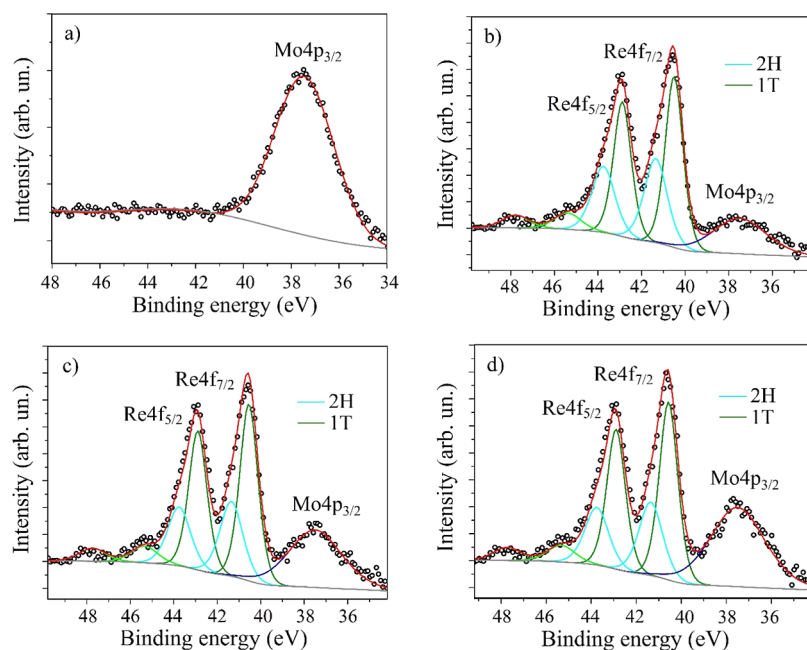


Figure 5. XPS core-level Re 4f spectra of grown $\text{Mo}_{1-x}\text{Re}_x\text{S}_2$ films: Mo1.5-6 (a), Mo1.5-6-Re (b), Mo2.5-4-Re (c), and Mo4.1-2-Re (d).

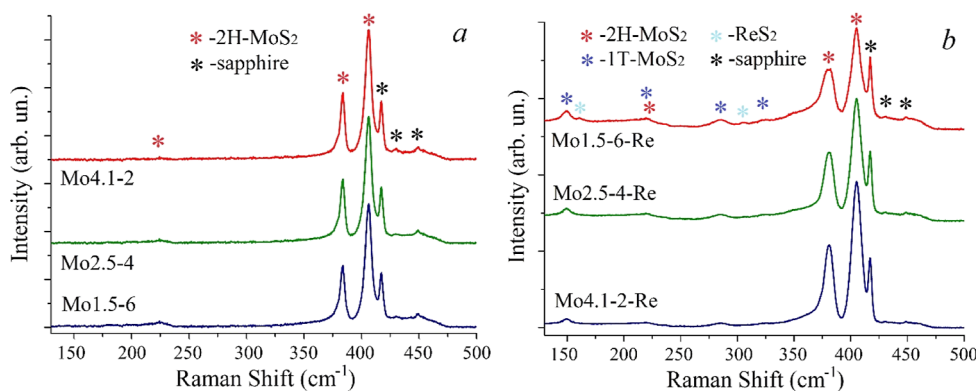


Figure 6. Raman spectra of MoS_2 (a) and $\text{Mo}_{1-x}\text{Re}_x\text{S}_2$ (b).

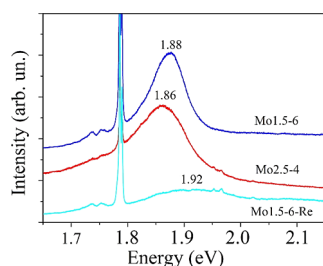


Figure 7. Photoluminescence spectra of Mo1.5-6, Mo2.5-4, and Mo1.5-6-Re films.

performance degradation in not less than 4 months and withstand annealing in high vacuum at a temperature of up to 300 °C. We also confirmed the film uniformity over the substrate by Raman spectroscopy (Figure S6). Since the measured $I(E_{1g})/I(A_{1g})$ intensity ratio exhibited only small fluctuations across the investigated sample, the phase composition seems to be quite uniform. Because in this experiment we were limited only by the inner diameter of the laboratory-scale furnace, we believe that the developed

MOCVD process is scalable on larger substrates if the conditions are optimized for a given equipment setup.

With respect to the literature data, the main applications of the obtained 1T/2H heterogeneous structures are related to catalysis and electronics but with several limitations on the substrate material. However, we do not see any fundamental limitation for employing the described method in the other substrates, which makes the results of potential interest for electronics. Often, a shortcoming of the synthesized 2H- MoS_2 films is a rather high resistance at MoS_2 -metal contact, which limits the achievable I_{on} current in field-effect transistors (FETs). Since the 1T phase conductivity is $\sim 10^7$ times higher compared to that of the 2H one,²⁰ the film resistance may be tuned by changing the 1T phase concentration.

Therefore, the 1T phase influence on the films' electrical properties of four films with a different phase composition was also investigated: Mo1.5-6, Mo1.5-6-Re, Mo2.5-4-Re, and Mo4.1-2-Re. Specifically, the resistivity of these films was measured, and it was found that the measured values are quite uniformly distributed across the films' surface. In Figure 8, the averaged resistance for each investigated sample is provided depending on the E_{1g} to A_{1g} Raman peak intensity ratio which

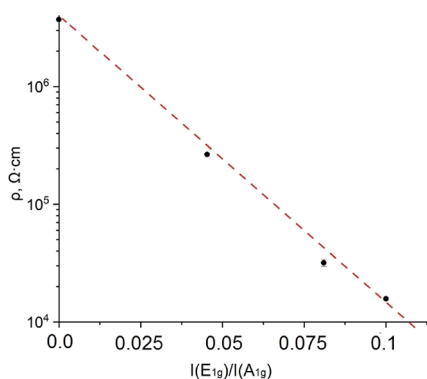


Figure 8. Resistivity dependence on the $I(E_{1g})/I(A_{1g})$ Raman peak ratio, corresponding to the 1T phase fraction.

is proportional to the 1T-MoS₂ fraction. As the figure suggests, the film resistivity anticorrelates with the fraction of the 1T-phase. Moreover, this dependence is exponential. One of the possible explanations for this fact is that the film's conductivity is determined by the density of highly-conducting 1T-MoS₂ grains, due to the changing average distance between them, as it is described in ref 45. However, for polycrystalline films studied in this work, the resistivity value should be governed by the film's structure with its high resistivity owing to the combination of relatively small crystalline size and high intergrain boundary resistance. We believe that this is the origin of high resistivity found in the studied films, which is 15 k Ω ·cm for films with the highest 1T fraction and as high as 2 M Ω ·cm for the film with the lowest 1T fraction. On one hand, the crucial role of the intergrain boundaries for polycrystalline TMDC films' conductivity is already well known.^{46–48} On the other hand, sheet resistances reported for single nanosheets and flakes with induced 1T phase transition are significantly lower reaching hundreds of Ω/\square for the few-layered material.^{49,50} The data directly relevant for the investigated films on synthesized large-area thin 1T-MoS₂ films' resistivity is lacking, as 1T-MoS₂ is unstable and challenging to fabricate.²⁰ In the work,⁵¹ a resistivity of up to 1 k Ω ·cm is reported for 1T MoS₂ nanosheets, consisting of coalesced overlapping grains. Another work⁵² reports the significant resistance increase in a magnetron-deposited MoS₂ film, annealed at high temperatures, up to 8 M Ω/\square for a 50 nm film annealed at 900 °C. Authors suggest that this increase is caused by grain boundaries' formation, accompanying grain crystallization. Overall, we believe that substantially different film resistance in our structures is due to the polycrystalline structure of the material, which consists of poorly coalesced separate grains with a high intergrain resistance value.

CONCLUSIONS

In this work, the process of metastable 1T phase formation in MOCVD of rhenium-doped MoS₂ films was studied. The rhenium concentration was controlled by varying the Mo precursor flow rate. The concentration of the rhenium precursor in the form of samples with pre-deposited ReO_x particles was maintained constant. This method allows for film synthesis over the large scale. Deposition regimes were determined, allowing us to fabricate the films with nanoscale 1T-MoS₂ and 2H-MoS₂ domains. XPS and Raman spectroscopy investigation suggests that the 1T-MoS₂ fraction increases with the increasing Re concentration, attributed to Mo_{1-x}Re_xS₂

film growth rate decrease. At a Re concentration above 5 at. %, saturation is observed. The maximal 1T-MoS₂ fraction obtained is 30% at a Re concentration of 8 at. %. At this concentration, ReS₂ phase formation indications are observed. Octahedral coordination in MoS₂ is assumed to be formed due to higher electron density, induced by excess electrons at the Re outer d-shell. Fabricated heterogeneous 1T/2H-MoS₂ films remain stable under ambient conditions without performance degradation for at least 4 months and withstand high-vacuum annealing at 300 °C. These films might also be of interest for electronic applications as increase of the 1T phase fraction is shown to decrease films' resistivity; it was found to be 130 times less for the film without 1T-MoS₂ than that for the film with the 30% 1T fraction.

ASSOCIATED CONTENT

Supporting Information

The Supporting Information is available free of charge at <https://pubs.acs.org/doi/10.1021/acsomega.2c06794>.

ReO_x deposition scheme and MOCVD MoS₂ deposition scheme; growth conditions and resulting MoS₂ film thicknesses; AFM image of the Mo1.5–3 film edge (measured thickness profile); AFM image of a sapphire substrate covered with rhenium oxide particles used in the consequent MOCVD process; XPS spectrum of Re4f core levels of the sapphire substrate, covered with ReO_x particles; bright-field (SAED pattern) and dark-field TEM images of the Mo2.5–4-Re film; and Raman spectra of the Mo2.5–4-Re film at different points across the sample and E_{1g}/A_{1g} intensity ratio as a function of the measurement point coordinate (PDF)

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Notes

The authors declare no competing financial interest.

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